



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Motoyuki Tsuihiji et al. Art Unit : 3723
Serial No. : 10/781,009 Examiner : Alvin J. Grant
Filed : February 18, 2004
Title : METHOD OF FABRICATING A SEMICONDUCTOR DEVICE

Mail Stop Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF JULY 2, 2004

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Oct. 4, 2004

Date of Deposit

Paula T. Romeo

Signature

PAULA T. ROMEO

Typed or Printed Name of Person Signing Certificate